REPORT DOCUMENTATION PAGE			Form Approved OMB No. 0704-0188
Public reporting burden for this collection gathering and maintaining the data neede collection of information, including sugge Davis Highway, Suite 1204, Arlington, V.	of information is estimated to average 1 hour p id, and completing and reviewing the collection stions for reducing this burden to Washington H A 22202-4302, and to the Office of Manageme	I her response, including the time for n of information. Send comments reg leadquarters Services, Directorate fo ant and Budget, Paperwork Reduction	eviewing instructions, searching existing data sources arding this burden estimate or any other aspect of this r Information Operations and Reports, 1215 Jefferson n Project (0704-0188), Washington, DC 20503.
1. AGENCY USE ONLY (Leave blank	2. REPORT DATE September 10, 1997	3. REPORT TYPE AND D Final Report	ATES COVERED
4. TITLE AND SUBTITLE	<u> </u>		5. FUNDING NUMBERS
Electrostrictive Mechanisms in Polyurethane and Other Polymer Films			N00014-94-1-0449 R&T Code 3132102 Kenneth J. Wynne
6. AUTHOR(S)			
D. J. Klingenberg, M	4. J. Winokur, and S. L. Coope	r	
7. PERFORMING ORGANIZATION NA	AMES(S) AND ADDRESS(ES)		8. PERFORMING ORGANIZATION
Department of Chemical University of Wisconsin 1415 Engineering Drive Madison, WI 53706	Engineering		REPORT NUMBER
9. SPONSORING / MONITORING AGENCY NAMES(S) AND ADDRESS(ES) Department of the Navy Office of Naval Research 800 N. Quincy Street Arlington, VA 22217-5000			10. SPONSORING / MONITORING AGENCY REPORT NUMBER
a. DISTRIBUTION / AVAILABILITY STATEMENT Reproduction in whole, or in part, is permitted for any purpose of the United			2. DISTRIBUTION CODE
Reproduction in whole, or	in part, is permitted for any p	urpose of the United	
Reproduction in whole, or States Government. This sale, its distribution is unl	in part, is permitted for any p document has been approved f imited.	urpose of the United or public release and	
Reproduction in whole, or States Government. This sale, its distribution is unl 13. ABSTRACT (Maximum 200 word	in part, is permitted for any p document has been approved f imited.	urpose of the United or public release and	
Reproduction in whole, or States Government. This sale, its distribution is unl 13. ABSTRACT (Maximum 200 word Electrostriction is the elastic nuch larger than those of pic lectrostriction in thin polym ontrol observed behavior. lue to electrostatic forces. overn electrostriction, and or electrostriction of amorph arameters for a variety of po	in part, is permitted for any p document has been approved f imited. (c) (c) (c) (c) (c) (c) (c) (c) (c) (c)	urpose of the United or public release and used by an electric field unic materials. Our rese derlying mechanism or m ntal observations can b is been correctly identif ure them. We have al predictions agree very	Achievable deformations can be arch has focused on understanding nechanisms and the properties that e described as elastic deformation ying the dielectric properties that so developed a microscopic model well with measured electrostriction
Reproduction in whole, or States Government. This sale, its distribution is unl 13. ABSTRACT (Maximum 200 word Electrostriction is the elastic nuch larger than those of pi- lectrostriction in thin polym ontrol observed behavior. The to electrostatic forces. overn electrostriction, and or electrostriction of amorph parameters for a variety of po-	in part, is permitted for any p document has been approved f imited. su c deformation of a material can ezoelectric polymers and inorga her films — determining the und We have shown that experime Critical to this conclusion has developing techniques to meas nous, polarizable solids. Model olymer films.	urpose of the United or public release and used by an electric field unic materials. Our rese derlying mechanism or m ntal observations can b is been correctly identifi ure them. We have al predictions agree very	Achievable deformations can be arch has focused on understanding nechanisms and the properties that e described as elastic deformation ying the dielectric properties that so developed a microscopic model well with measured electrostriction
Reproduction in whole, or States Government. This sale, its distribution is unl 13. ABSTRACT (Maximum 200 word Electrostriction is the elastic nuch larger than those of pi- lectrostriction in thin polym ontrol observed behavior. Thue to electrostatic forces. overn electrostriction, and or electrostriction of amorph arameters for a variety of po- arameters for a variety of po-	in part, is permitted for any p document has been approved f imited.	urpose of the United or public release and used by an electric field unic materials. Our rese derlying mechanism or m ntal observations can b is been correctly identif ure them. We have al predictions agree very	Achievable deformations can be arch has focused on understanding nechanisms and the properties that e described as elastic deformation ying the dielectric properties that so developed a microscopic model well with measured electrostriction
Reproduction in whole, or States Government. This sale, its distribution is unl 13. ABSTRACT (Maximum 200 word Electrostriction is the elastic nuch larger than those of pi- lectrostriction in thin polym ontrol observed behavior. Thue to electrostatic forces. overn electrostriction, and or electrostriction of amorph arameters for a variety of po- 4. SUBJECT TERMS	in part, is permitted for any p document has been approved f imited.	urpose of the United or public release and used by an electric field unic materials. Our rese derlying mechanism or m ntal observations can b is been correctly identifi ure them. We have all predictions agree very	1. Achievable deformations can be arch has focused on understanding nechanisms and the properties that e described as elastic deformation ying the dielectric properties that so developed a microscopic model well with measured electrostriction         15. NUMBER OF PAGES         16. PRICE CODE

#### OFFICE OF NAVAL RESEARCH

#### GRANT N00014-94-1-0449

#### PR Number 3132102

## FINAL REPORT

#### "Electrostrictive Mechanisms in Polyurethane and Other Polymer Films"

by

Daniel J. Klingenberg\*, Michael J. Winokur<sup>†</sup>, and Stuart L. Cooper<sup>‡</sup>

Departments of Chemical Engineering<sup>\*</sup> and Physics<sup>†</sup> University of Wisconsin 1415 Johnson Drive Madison, WI 53706 and Department of Chemical Engineering<sup>‡</sup> University of Delaware Newark, DE 19716-3110

September 10, 1997

Reproduction in whole, or in part, is permitted for any purpose of the United States Government.

This document has been approved for public release and sale, its distribution is unlimited.

# 19970924 101

#### Electrostrictive Mechanisms in Polyurethane and Other Polymer Films

FINAL REPORT

September 10, 1997

Daniel J. Klingenberg, University of Wisconsin Stuart L. Cooper, University of Delaware Michael J. Winokur, University of Wisconsin

## 1 Research Summary

Electrostriction is the elastic deformation of a material caused by an electric field. Achievable deformations can be much larger than those of piezoelectric polymers and inorganic materials. Our research has focused on understanding electrostriction in thin polymer films — determining the underlying mechanism or mechanisms and the properties that control observed behavior.

We have shown that experimental observations can be described as elastic deformation due to electrostatic forces. Critical to this conclusion has been correctly identifying the dielectric properties that govern the electrostatic stress. and developing techniques to measure them.

We developed a linear theory for simple materials which introduces five material parameters governing electrostriction: the relative dielectric constant,  $\epsilon^0$ , two derivatives of the dielectric tensor with respect to strain components.  $a_1$  and  $a_2$ , Young's modulus,  $E_y$ , and Poisson's ratio,  $\nu$ . Knowledge of these parameters and appropriate boundary conditions allow one to predict field-induced deformations.

Of these parameters,  $a_1$  and  $a_2$  had not previously been measured for systems of interest. We have developed several techniques to measure these parameters, based on the simultaneous measurement of deformation and permittivity in thin polymer films. One experimental apparatus, shown schematically in Figure (1), consists of a



Figure 1: Schematic diagram of the polymer-air-polymer capacitor assembly. The electrodes are glued to the glass slides. The two polymer films, obtained by cutting a single film in half, act as a spacer for center air-gap capacitor.

polymer-film capacitor integrated with an air-gap capacitor. Deformation induced by an applied field is determined from the change in capacitance of the air-gap capacitor, while the electrostriction parameters are determined by the change in capacitance of the polymer-film capacitor. We have also developed a microscopic model for electrostriction of amorphous, polarizable solids. The electrostriction parameters are predicted to be functions of only the dielectric constant of the nondeformed solid,  $\epsilon^0$ ,

$$a_1 = -\frac{2}{5}(\epsilon^0 - 1)^2, \tag{1}$$

$$a_2 = -\frac{1}{3}(\epsilon^0 - 1)(\epsilon^0 + 2) + \frac{2}{15}(\epsilon^0 - 1)^2.$$
<sup>(2)</sup>

The measured parameters agree very well with this microscopic model, as illustrated in Figure (2). The electro-



Figure 2: Sum of electrostriction coefficients,  $a_1 + a_2$ , as a function of the polymer dielectric constant. The solid curve is the prediction from the microscopic model, and the symbols are experimental data for a Kraton (SIS, Shell) and two polyurethane elastomeric films.

static stress driving the deformation contains two contributions—the Coulombic attraction between the bounding electrodes, and "pure electrostriction" which is linear in the quantity  $-(a_1 + a_2)$ . The measured parameter values indicate that the deformation arising from pure electrostriction is > 10× that arising from Coulombic attraction for polyurethane elastomers. Thus, understanding the relationships between  $a_1$ ,  $a_2$  and material chemistry is crucial for future development of electrostrictive materials.

# 2 Personnel

Name	Classification	
Eric Ding (Wisc.)	Graduate Student	
Yuri Shkel (Wisc.)	Postdoc	
Kristen Hartley (Wisc.)	Undergraduate	
Alastair Steel (Wisc.)	Undergraduate	
Phil Jackson (Del.)	Graduate Student	
Saumitra Bhargava (Del.)	Graduate Student	
George A. Cragg (Del.)	Undergraduate	
Laura L. Zeafla (Del.)	Undergraduate	

# **3** Publications and Presentations

1. "Electrostriction of Polarizable Materials. Comparison of Models with Experimental Data," Y. M. Shkel and D. J. Klingenberg, J. Appl. Phys., submitted (1997).

The significance of this publication is that we relate dielectric properties that govern electrostrictive stresses to other, more common properties, namely the dielectric constant of nondeformed medium. We also show that a simple microscopic model agrees very well with experimental data.

 "Material Parameters for Electrostriction," Y. M. Shkel and D. J. Klingenberg, J. Appl. Phys., 80, 4566-4572 (1996).

In this paper, we outline a linear continuum theory for electrostriction, whereby deformation of an elastic medium in an electric field is caused by electrostatic stresses. The stress magnitudes are determined by two material parameters. We describe an experimental technique for measuring these parameters, and present the first experimental data for these parameters for polyurethane elastomers.

3. "Electrostatics at Rough Interfaces," D. J. Klingenberg and S. L. Cooper, J. Electrostatics, 35, 339-348 (1995).

This paper describes how interfacial roughness can alter the electrostatic field and the resulting stresses at interfaces. Interfacial roughness can have a large impact on force magnitudes, but determining this contribution requires measuring roughness on all length scales.

- 4. "Dielectric Parameters for Electrostatic Forces in Solids," Y. M. Shkel and D. J. Klingenberg, American Physical Society Meeting, Kansas City, MO, Mar. 17-21, 1997.
- 5. "Material Parameters for Polymer Electrostriction," Y. M. Shkel and D. J. Klingenberg, Society of Rheology Meeting, Galveston, TX, Feb. 16-20, 1997.
- "Measurement of Electrostrictive Properties of Polymers," Y. M. Shkel, E. R. Ding, K. L. Hartley, A. G. Steel, and D. J. Klingenberg, American Institute of Chemical Engineers Annual Meeting, Chicago, IL, Nov. 11-15, 1996.
- 7. "Electrostriction in Polymer Films," Department of Chemical Engineering, University of Michigan, Ann Arbor, September 19, 1996.
- 8. "Overview of Research Projects," presented to S. C. Johnson Wax, Madison, WI, Jan. 23, 1996.
- 9. "Electrostrictive Polyurethane Films," D. J. Klingenberg, ONR Program Review, Rutgers University, NJ, May, 1995.
- 10. "Electrostatics at Rough Surfaces," D. J. Klingenberg and S. L. Cooper, ONR Workshop on Transducer Materials and Transducers, State College, PA, April, 1995.
- 11. "Electrostriction of Polyurethane Films," D. J. Klingenberg, S. L. Cooper, and M. J. Winokur, ONR Transducers and Transducer Materials Workshop, University Park, PA, April 10-13, 1994.

- 12. "Maxwell Stress Calculations in Heterogeneous Materials," Philip L. Jackson, APS Meeting, San Jose, CA March 23, 1995.
- 13. "Maxwell Stresses in Heterogeneous Materials," Philip L. Jackson, ONR Program Review, Rutgers, May 17, 1995.
- 14. "Electrically Induced Stress and Strain in Block Copolymers," Philip L. Jackson, APS Meeting, Pittsburgh, PA, March 24, 1994.

## 4 Interactions

٠

We have had one significant scientific interaction with Dr. Ed Balizer from the Naval Surface Warfare Center in Bethesda, MD. The objective of this interaction was to use our experimental techniques to measure electrostriction parameters of films prepared by Dr. Balizer. The two main conclusions from this interactions are (1) that different polyurethane elastomers appear to have similar values for the electrostriction parameters  $a_1$  and  $a_2$ , and (2) that field-induced deformations are also sensitive to differences in the mechanical properties of the films (Young's modulus and Poisson ratio).